

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of: **Toshifumi MORI**

Serial Number: **Not Yet Assigned**

Filed: **August 27, 2003**

For: **SEMICONDUCTOR DEVICE WITH ELEVATED SOURCE/DRAIN STRUCTURE
AND ITS MANUFACTURE METHOD**

INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

August 27, 2003

Sir:

In compliance with 37 CFR 1.56, Applicant calls to the attention of the Patent and Trademark Office the reference listed on the attached PTO-1449.

A copy of the reference is enclosed herewith.

In the event there are any fees due in connection with the filing of this paper, please charge

Deposit Account No. 01-2340.

Respectfully submitted,

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PATENT TRADEMARK OFFICE

Enclosures: PTO-1449; References (1)

**INFORMATION
DISCLOSURE
STATEMENT
PTO-1449**

Atty. Docket No. 030957 Serial No. New Application

Applicant(s): Toshifumi MORI

Filing Date: August 27, 2003 Group Art Unit: Not Yet Assigned

U.S. PATENT DOCUMENTS

Examiner Initial	Document No.	Name	Date	Class	Subclass	Filing Date (If appropriate)
_____	AA					
_____	AB					
_____	AC					
_____	AD					

FOREIGN PATENT DOCUMENTS

	Document No.	Date	Country	Translation (Yes or No)
_____	AE	3209731	07/13/01 Japan	Yes-Abstract/Discussed in the specification
_____	AF			
_____	AG			
_____	AH			
_____	AI			

OTHER DOCUMENTS

_____	AJ	
_____	AK	
Examiner	Date Considered	